

DE CMP-832 DUAL COMPONENT PUMP



APPLICATIONS

- Bonding
- Sealing
- Gasketing
- Filling

MATERIALS

- Silicones
- Epoxies
- Urethanes
- MMA

FEATURES AND BENEFITS

- AST CMP metering pump
- Viscosities up to 1,000,000 cps
- Pneumatic powered
- Continuous flow up to 4 gpm
- System diagnostic check available
- Fluid pressures up to 3,000 psi
- Metered shots or continuous flow
- Automatic dispense valve
- Adjustable flow rate
- Handles abrasive materials

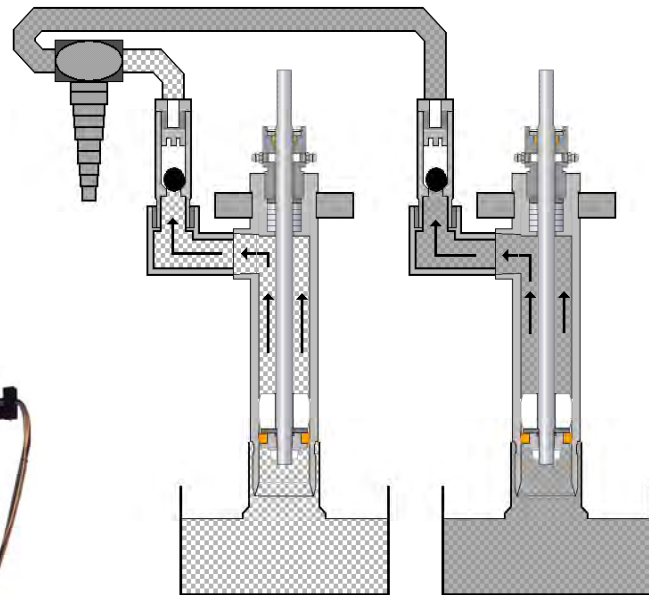
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PRODUCT SPECIFICATIONS

Applications for the DE 832 DUAL COMPONENT PUMP for Silicones, Urethanes, Epoxies and General Adhesives include:

- Sealing
- Bonding
- Caulking
- Gasketing



MODEL	DE CMP-832	RATIO RANGE	4:1 – 10:1
DRIVE SYSTEM	6" – 10" Dia. Air Cylinder	CYCLE RATE	Up to 30 cycles per minute
OUTPUT	Up to 4 gpm depending on size, viscosity & hose	DISPENSE MANIFOLD	Manual or Automatic; Fixed or hand-held
CONTAINERS	8-1/2 or 55 Gal.	POWER FACTOR	5:1 – 30:1
VISCOSITY RANGE	1 – 1,000,000 cps	SHOT SIZE	Up to 0.25 gal. per stroke
ACCURACY	Within 2% of shot	STROKE SIZE	Up to 6" per stroke
CONTROLS	Pneumatic/On-Off switch	SHOT ADJUSTMENT	0 - 100% of full stroke

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